NOTES:

1. SUBSTRATE MATERIAL: FUSED SILICA

- 2. SURFACE S2 TO BE PARALLEL TO SURFACE S1 <3 ARCSEC
- COATING (APPLY ACROSS COATING APERTURE) S1: ULTRAFAST LASER Rs >99.75% @ 500 - 530nm @ 45° AOI Rp >99.5% @ 500 - 530nm @ 45° AOI

S2: STRESS COMPENSATING COATING

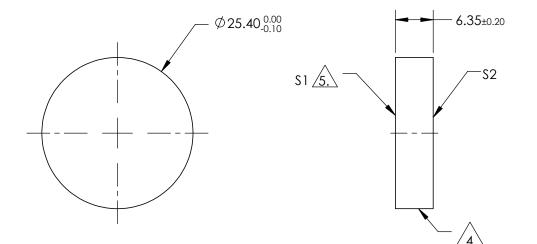
GROUP DELAY DISPERSION: ±20fs² @ 500 - 530nm (S-POL & P-POL)

DAMAGE THRESHOLD: 0.17 J/cm² @ 515nm, 178fs, 1 pulse (typical) 0.15 J/cm² @ 515nm, 178fs, 10kHz, 1000 pulses (typical)

4. FINE GROUND SURFACE

5. SURFACE ROUGHNESS: RMS

6. RoHS: COMPLIANT



FOR INFORMATION ONLY: DO NOT MANUFACTURE PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

SHAPE	S1 PLANO	S2 PLANO			Edmund Optic	CS®
SURFACE FLATNESS	λ/8	N/A	1			
SURFACE QUALITY	10-5	COMMERCIAL POLISH	THIRD ANGLE	TITLE	500 - 530nm, 25.4mm Dia., Low GDD UI	trafast
CLEAR APERTURE (%)	90%	N/A			Mirror	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	12834	SHEET 1 OF 1